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05/21/2008

1110-94326 PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Pl. No. : 10/534,946
Applicant : YOKOYAMA et al.
Filed : 11 May 2005
Art Unit : 1792
Examiner : SONG, Mathew J.
Docket No. : 1110-94326
Customer No. : 24628
Title : SILICON WAFER, ITS
MANUFACTURING METHOD, AND ITS
MANUFACTURING APPARATUS

Confirmation No.: 3657

**CERTIFICATE OF MAILING BY
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9 April 2008
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AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

The Office Action of January 10, 2008 has been carefully reviewed and the following
amendments and remarks are made in response thereto: